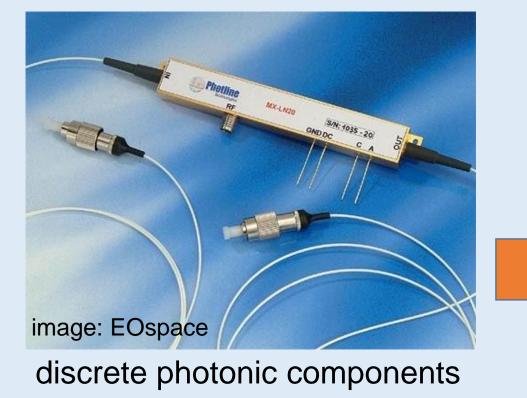


# Background

### **Photonic Integrated Circuits**

- Integration of photonic waveguide components onto single semiconductor die: lasers, modulators, filters, detectors
- Uses similar foundry tools, processes, and materials as electronic ICs



 Low SWAP-C electro-optic systems for commercial and DOD applications

photonic integrated circuits

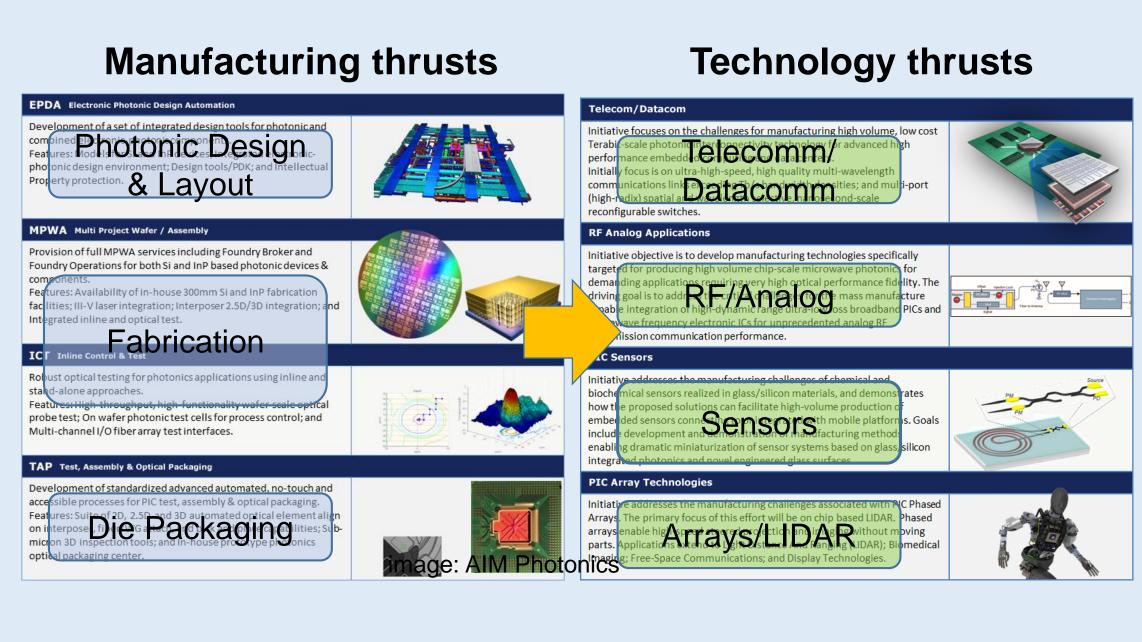


### **AIM Photonics**

Public-private partnership • established by the DOD in 2016 to create US foundry for photonic integrated circuits



• Aims to emulate the dramatic successes experienced by the electronics industry over the past 40 years and transition key lessons, processes, and approaches to the photonic integrated circuit (PIC) industry.



Initial emphasis was on telecomm/datacomm, *not sensors* 

**Todd H. Stievater, Nathan F. Tyndall (Naval Research Laboratory)** 

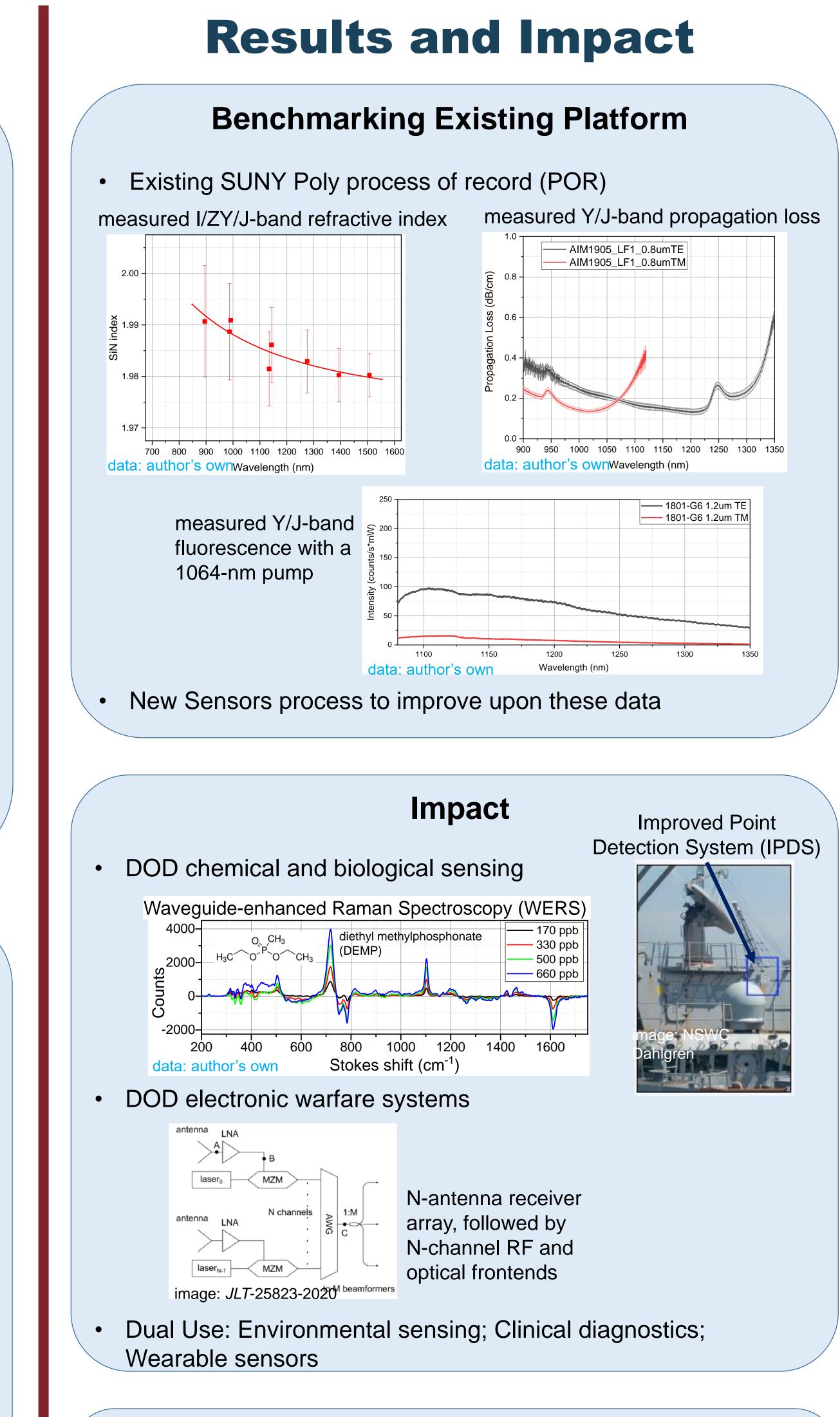
Ultra-Low-Loss Passive Photonic IC Platform for Sensors

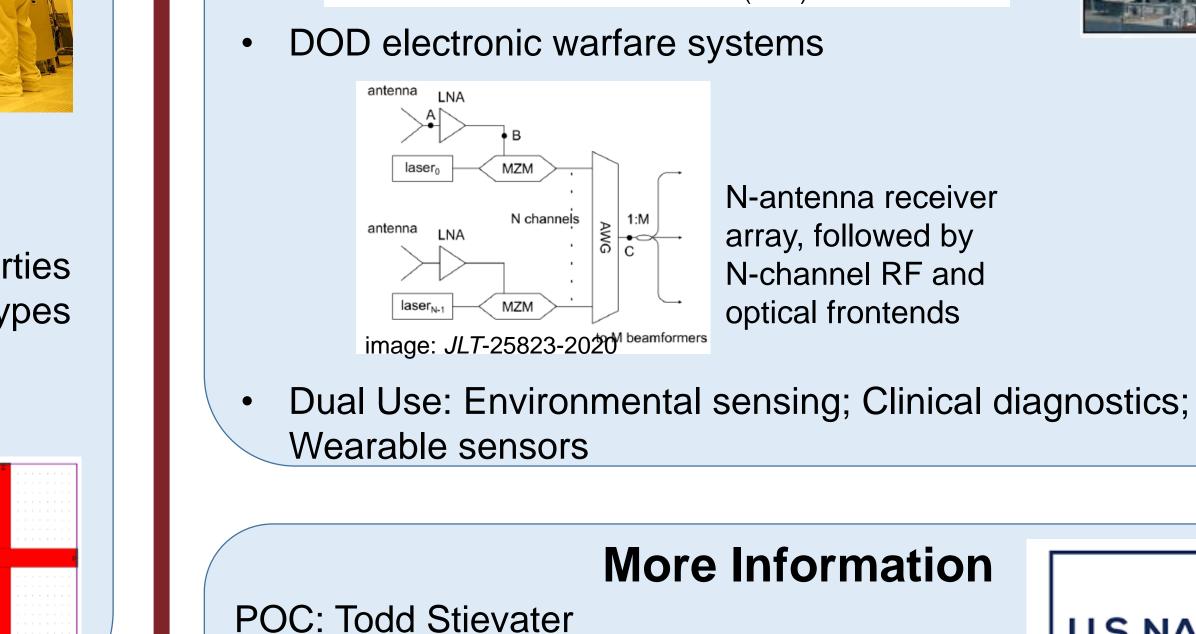
## Approach

PICs for Sensors v	s. Datacomm/Telecomm
• TE mode only	eration (1300 nm $\rightarrow$ 1600 nm) only ponents (>GB/s modulators and onment
<ul> <li>Sensors PICs require</li> <li>O-band, C-band, plus I/</li> <li>TE, TM, nanoslot mode</li> <li>Low-loss passive platfor</li> <li>Sensing region for intera-</li> <li>Ultra-low waveguide flue</li> </ul>	rm (initially) action with analytes orescence
TM00 mode at 1064 nm	waveguide spiral in a sensing trench
Sensing film SiN SiO2 image: author's own most of power is in cladding/sorbe	ent laser in signal out
Prog	gram Plan
<ul> <li>Identify best combination of materials for waveguide co (SiN type) and cladding (Sin type) for Sensors requirement</li> </ul>	re O2
materials for waveguide co (SiN type) and cladding (Si	re O2

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